
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENTIn re application of: **SARVER et al.**Attorney Docket No.: NSC1P286
P05740

Application No.: 10/727,188

Examiner: **ADAMS, G.**

Filed: December 2, 2003

Group: 3652

Title: **METHOD AND APPARATUS FOR STACKING
SEMICONDUCTOR WAFERS**

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being transmitted by facsimile to fax number 571-273-8300 to the U.S. Patent and Trademark Office on February 3, 2006.

Signed:


Francis J. Kalinski II, Esq.**AMENDMENT A**Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated November 4, 2005, please amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

Application No. 10/727,188
NSC1P286/ P05740

Page 1 of 11